

Application No.	Applicant(s)	
10/767,273	LEE ET AL.	
Examiner	Art Unit	
James K. Truiillo	2116	

	SEARCHED				
Class	Subclass	Date	Examiner		
7/3	400,401 500,600	8/23/04	IKT		
365	233,230.01	4	1		
327	284	V	Y		
711	167	1.	V		
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
713	400,401	8/23/04	At T	
365	233	8/25/04		
327	284	+	1	
7"	167	1	1	

	SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR			
DATABASES SEARCHED'S EAST NPLI IEEE, ACM	8/22/04 \$\ \ 8/25/04	AKT			
NPLI ILEE, ACM	8/25/04				
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